



Attorney Docket No. 0756-7283

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit: 2814
Koichiro TANAKA et al.	)	Examiner: A. Chambliss
Serial No. 10/815,813	)	<u>CERTIFICATE OF MAILING</u>
Filed: April 2, 2004	)	I hereby certify that this correspondence is
For: LASER IRRADIATION METHOD,	)	being deposited with the United States Postal
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MANUFACTURING	)	Commissioner for Patents, P.O. Box 1450,
SEMICONDUCTOR DEVICE	)	Alexandria, VA 22313-1450, on January 13,
	)	2006.
	)	<i>Adrian M. Stamps</i>

**RESPONSE TO ELECTION REQUIREMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Dear Sir:

In response to the election requirement in the Office Action of December 13, 2005, Applicant hereby elects without traverse Species A2 directed toward patterning a crystalline semiconductor film and forming a channel in semiconductor layer. Claims 29-46 read on the elected species. Further, claims 1-18 are generic in that these claims do not recite features designated in either species A1 and A2.

Thus, claims 1-18 and 29-46 are subject to examination at this time.

Examination on the merits is requested.

Respectfully submitted,

  
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